



*Law* *13*

In re Application of:

YOSHINOBU SEKIGUCHI, et al.

Application No.: 10/566,170

371(c) Date: January 27, 2006

For: SEMICONDUCTOR FILM  
MANUFACTURING METHOD AND  
SUBSTRATE MANUFACTURING METHOD

Docket No. 00862.109138.

Examiner: Calvin Lee

Group Art Unit: 2818

Date: January 15, 2008

Mail Stop Amendment  
THE COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

☐ No additional fee is required.

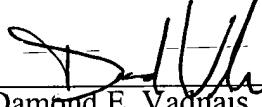
The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 15	MINUS	** 31	= 0	x \$25 \$50	\$ 0.00
INDEP. CLAIMS	* 7	MINUS	*** 3	= 4	x \$105 \$210	\$840.00
Fee for Multiple Dependent claims \$185°/\$370						\$ 0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$840.00

- \* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.  
\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.  
\*\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

- ☐ Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☒ A check in the amount of \$840.00 is enclosed.
- ☐ Charge \$\_\_\_\_\_ to Deposit Account No. 06-1205.
- ☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.
- ☐ A check in the amount of \$\_\_\_\_\_ to cover the fee for a \_\_\_\_\_ month extension is enclosed.
- ☒ A check in the amount of \$180.00 to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' undersigned attorney may be reached in our Costa Mesa, California office by telephone at (714) 540-8700. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Diamond E. Vadnais  
Attorney for Applicants  
Registration No.: 52,310

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3800  
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00862.109138.

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

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January 15, 2008

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated October 15, 2007, please amend the  
above-identified application, as follows:

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope  
addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria,  
VA 22313-1450 on

January 15, 2008  
(Date of Deposit)

Damond E. Vadnais, Reg. No. 52,310  
(Name of Attorney for Applicants)

  
Signature

January 15, 2008  
Date of Signature

01/23/2008 AAHMADI 00000004 10566170

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